

**Supplementary Information for**

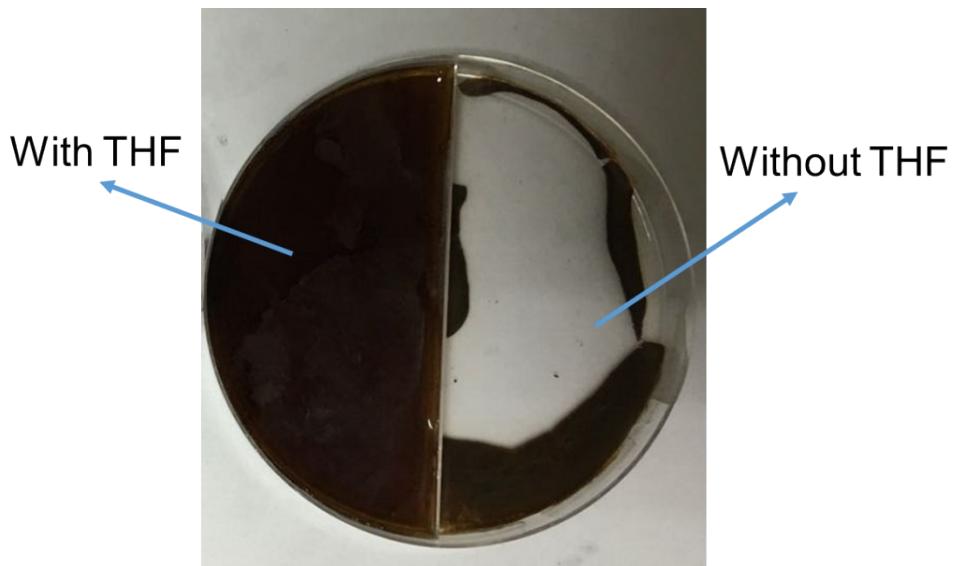
**Self-adapted and Tunable Graphene Strain Sensors for Detecting Both Gentle and  
Harsh Human Motions**

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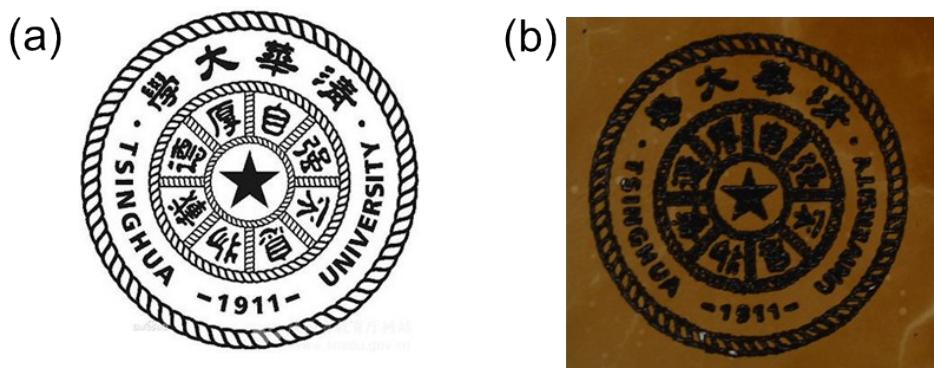
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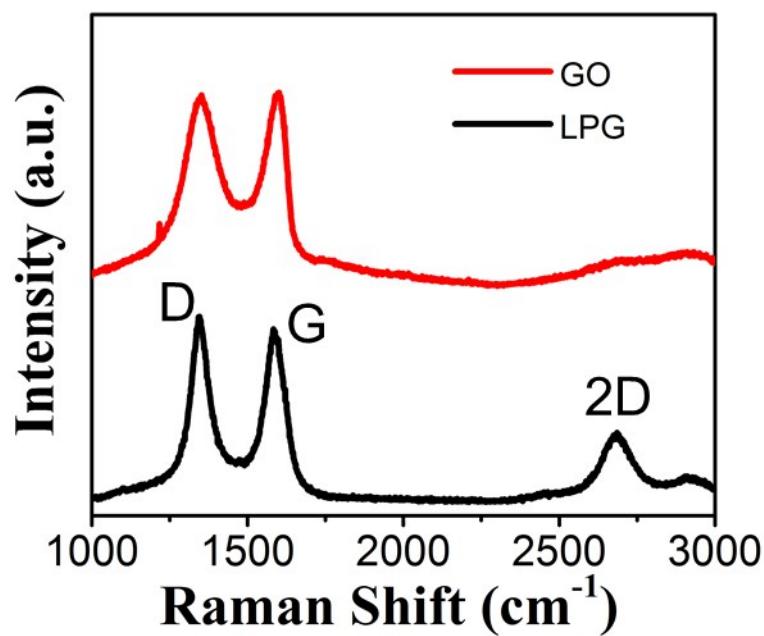
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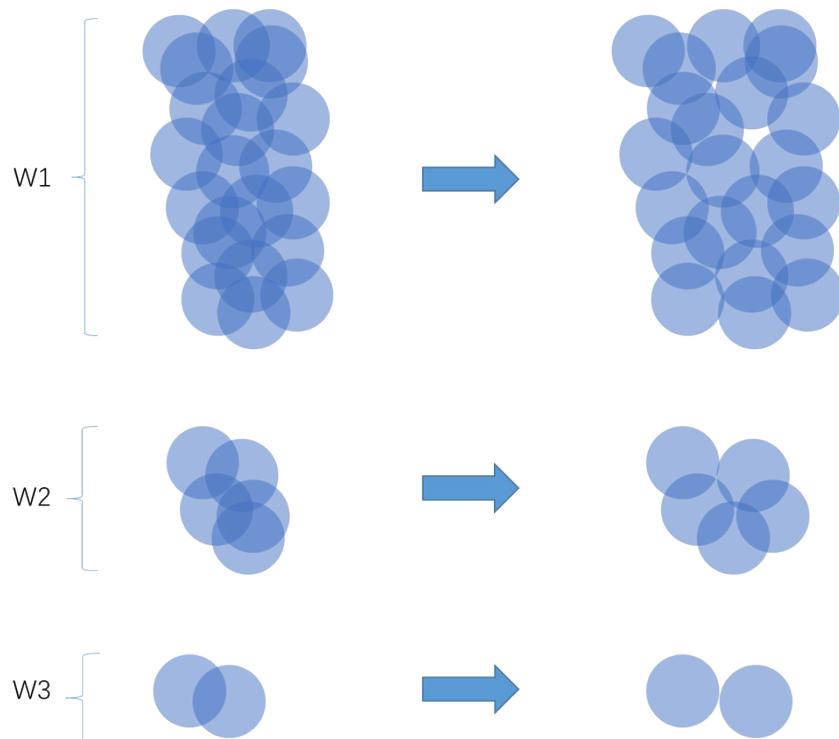
**Fig. S1** The left is the uniform film with THF and the right one is the broken film without THF.



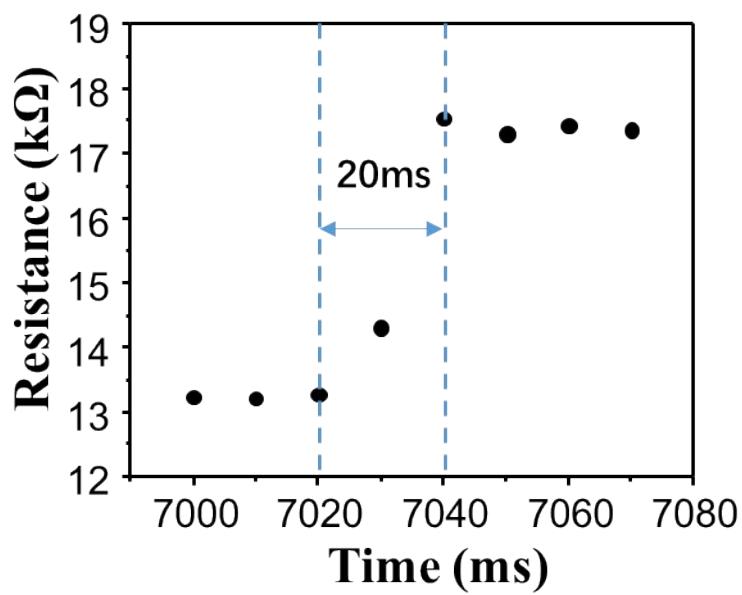
**Fig. S2** Laser scribing technology can realize precise patterning. (a) A predesigned pattern, the logo of Tsinghua University. (b) the graphene generated at precise locations.



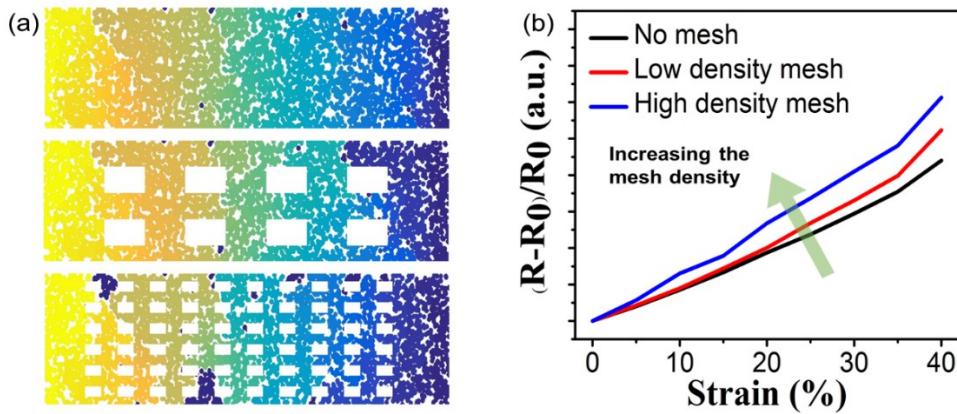
**Fig.S3** The Raman spectrum of GO and LPG. The LPG showing obvious 2D peak compared with GO.



**Fig.S4** The schematic illustration of the working principle. The no-mesh strain sensor contains a wide line (the width of the line is  $W_1$ ), while the high-mesh-density strain sensor contains a lot of thin lines (the width of the line is  $W_3$ ). It will be easier for a thin line to form open state. Therefore, the resistance of the high-mesh-density strain sensor will increase faster due to the formation of open line.



**Fig. S5** The response speed of LPG strain sensor is less than 20 ms.



**Fig.S6** Three models with different mesh densities were built to simulate the performance of the strain sensors. (a) The electric potential distribution in three models. (b) the simulation results of the strain sensors with different mesh densities.

Materials	Strain Range	Gauge Factor
Graphene microribbon <sup>1</sup>	10%	9.49
Graphene ripple <sup>2</sup>	30%	6.1
Graphene-Nanocellulose nanopaper <sup>3</sup>	100%	7.1
Graphene foam <sup>4</sup>	95%	2.3
Monolayer graphene <sup>5</sup>	4.5%	151
Pt Nanoparticles <sup>6</sup>	0.15%	75
Silver nanowires <sup>7</sup>	70%	116
Carbonized silk fabric <sup>8</sup>	500%	37.5
CNT-array double helices <sup>9</sup>	400%	12
Single-walled carbon nanotube <sup>10</sup>	280%	15
Nanographene by CVD <sup>11</sup>	1.6%	546
Pt-PDMS <sup>12</sup>	2%	2000
ZnO wire <sup>13</sup>	1.2%	1250
Laser patterned graphene flakes (no mesh)	<b>100%</b>	<b>268</b>
Laser patterned graphene flakes (high-density-mesh)	<b>35%</b>	<b>457</b>

Table 1. Performance comparison of graphene-based strain sensors

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